IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In Re Application | of: |) |
|--|---|--|
| Steven Ver | haberbeke et al. |) |
| Application No: | 09/891,849 |) Examiner: Markoff, Alexander |
| Filed: | June 25, 2001 |)) Art Unit: 1792 |
| For: METHOD AND APPARATUS FOR WAFER CLEANING | |))) |
| Commissioner for P.O. Box 1450 Alexandria, VA 22 | | |
| | AMENDMENT A | FTER FINAL |
| Dear Sir: | | |
| This is in re | sponse to the Final Office | Action mailed March 21, 2008, Advisory |
| Action mailed Jun | e 13, 2008, and the Request | for Continued Examination (RCE) |
| under 37 C.F.R. § | 1.114 filed concurrently her | ewith. Applicant respectfully requests |
| the Examiner to en | nter this Preliminary Amen | dment and consider the following |
| remarks. | | |
| | | |
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| postage in an envelope add COMMISSIONER FOR P | rrespondence is being deposited with the lressed to MAIL STOPATENTS, P.O. Box 1450, Alexandria, Office, Washington, D.C. 20231 on | |
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| Leresa M | The | Luna 22, 2009 |
| | ature | June 23, 2008 Date |

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Attorney Docket: 004711/P1
BSTZ Ref. No.: 004887.P454X